

Electronic Acknowledgement Receipt

EFS ID:	6372040
Application Number:	10689617
International Application Number:	
Confirmation Number:	4799
Title of Invention:	Method for cleaning plasma etching apparatus, method for plasma etching, and method for manufacturing semiconductor device
First Named Inventor/Applicant Name:	Satoru Okamoto
Customer Number:	26171
Filer:	Roberto J. Devoto/kim Bailey
Filer Authorized By:	Roberto J. Devoto
Attorney Docket Number:	12732-170001
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Application Type:	Utility under 35 USC 111(a)

Payment information:

Submitted with Payment	yes
Payment Type	Deposit Account
Payment was successfully received in RAM	\$540
RAM confirmation Number	8447
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)/ Message Digest	Multi Part /.zip	Pages (if appl.)
1		127320170001NOAP.pdf	374014 8808b42836f62461dd4d4e91ef8121c229af8cc4	yes	7
Multipart Description/PDF files in .zip description					
	Document Description		Start		End
	Notice of Appeal Filed		1		1
	Pre-Brief Conference request		2		7
Warnings:					
Information:					
2	Fee Worksheet (PTO-875)	fee-info.pdf	30178 8866e9f3c3d8514d3d499e80117d3c5b457e7f	no	2
Warnings:					
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Total Files Size (in bytes):			404192		
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